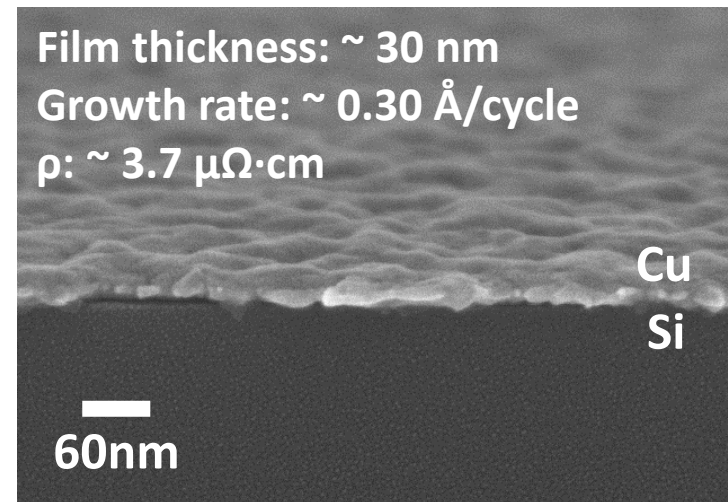
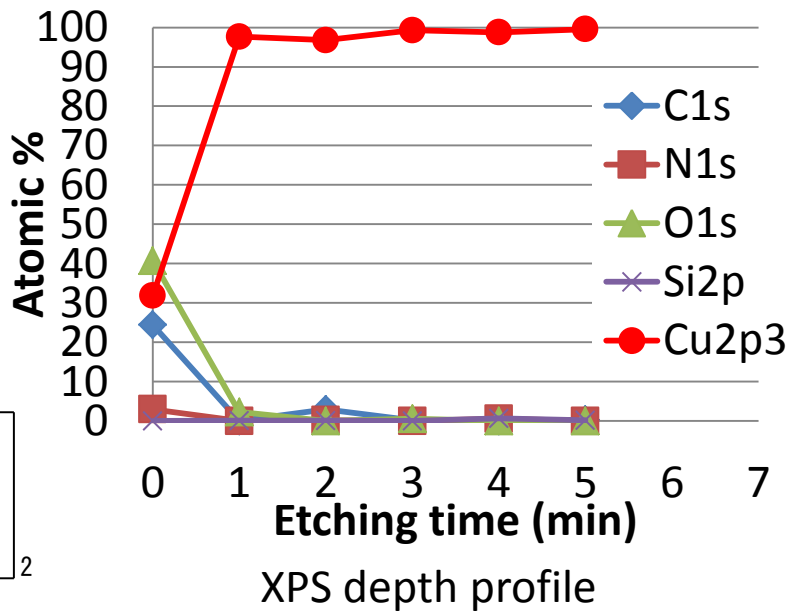
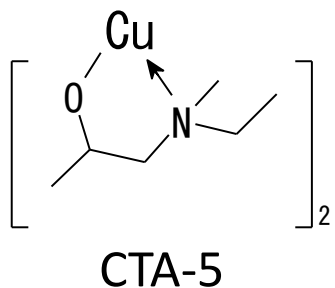
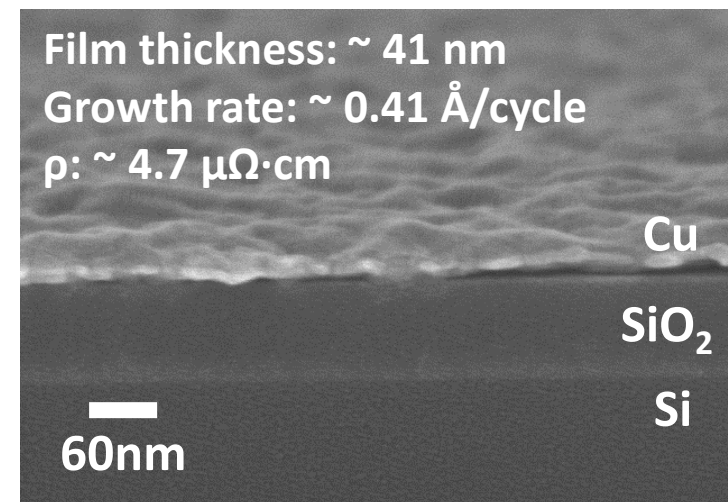
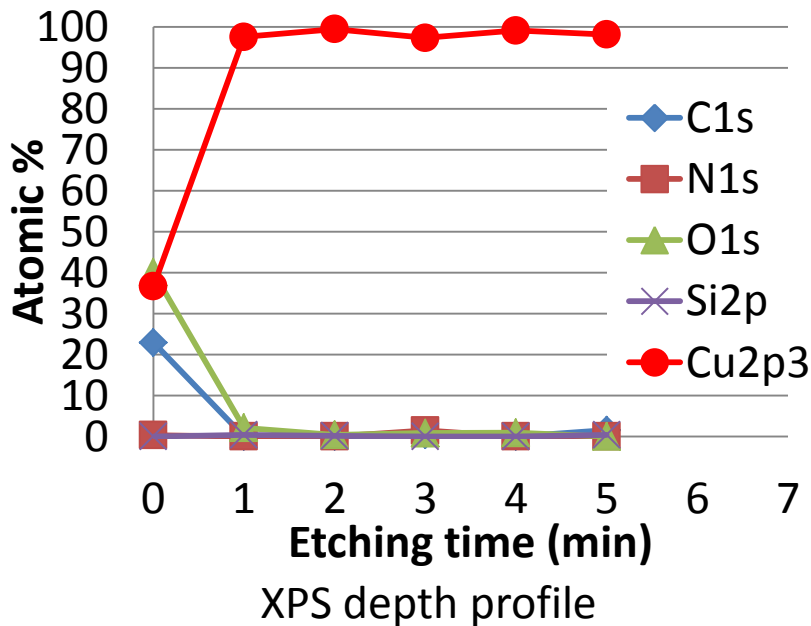


# CTA-5 + H<sub>2</sub> PE-ALD at 40C on Si and SiO<sub>2</sub> substrates



FE-SEM



FE-SEM